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Docket No.: 060188-0843

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of : Customer Number: 20277

Atsushi NISHIMURA, et al. Confirmation Number: 7438

Application No.: 10/830,134 : Group Art Unit: 2811

Filed: April 23, 2004 : Examiner: Not yet assigned

For: SEMICONDUCTOR DEVICE AND METHOD FOR FABRICATING THE SAME

INFORMATION DISCLOSURE STATEMENT

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached form PTO-1449. It is respectfully requested that the references be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement is being filed within three months of the U.S. filing date OR before the mailing date of a first Office Action on the merits. No certification or fee is required.

Each non-English language reference was first cited in a corresponding foreign application search report or office action and its relevance discussed therein. A copy of the

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foreign search report or office action, together with an English language version thereof, is attached for the Examiner's information.

Please charge any shortage in fees due in connection with the filing of this paper, including extension of time fees, to Deposit Account 500417 and please credit any excess fees to such deposit account.

Respectfully submitted,

McDERMOTT WILL & EMERY LLP

Michael E. Fogarty Registration No. 36,139

Please recognize our Customer No. 20277 as our correspondence address.

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Date: November 21, 2005

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INFORMATION DISCLOSURE CITATION IN AN APPLICATION									SERIAL NO. 10/830,134			
						APPLICANT Atsushi NISHIMURA, et al.						
(PTO-1449)						FILING DATE GROUP April 23, 2004 2811			P			
			U	.S. PATEN	NT I	OCUMENTS						
EXAMINER'S INITIALS	CITE NO.	Nu	Document Number mber-Kind Code2 (if known)	Publication Da MM-DD-YYYY		Name of Patentee or Applicant of Cited Document			Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear			
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			JP 2003-022985	1-24-2003		Matsushita Electric Industrial Co., Ltd.				w/English Abstract		
			JP 2002-146531	5-22-2002		Applied Materials Inc.				w/English Abstract		
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			JP 11-087272	3-30-1999		Fujitsu Ltd.				w/English Abstract		
			JP 10-032248	2-3-1998		Yamaha Corp				w/English Abstract		
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^{*}EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

1 Applicant's unique citation designation number (optional). 2 Applicant is to place a check mark here if English language Translation is attached.